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X-ray diffraction and X-ray photoelectron spectroscopy

characterization of sulfurized tin thin films deposited by thermal

evaporation

Hiroto Oomae^{1,*}, Takahito Eguchi², Kunihiko Tanaka³,

Misao Yamane⁴, Naofumi Ohtsu⁵

¹Department of Creative Engineering, National Institute of Technology, Kushiro College,

Otanoshike-Nishi 2-32-1, Kushiro, Hokkaido, Japan

² Education and Research Support Center, National Institute of Technology, Kushiro College, Otanoshike-Nishi 2-32-1, Kushiro, Hokkaido, Japan

³ Department of Electrical, Electronics and Information Engineering, Nagaoka University of Technology, 1603-1 Kamitomioka, Nagaoka, 940-2188 Niigata, Japan

⁴ Instrumental Analysis Center, Kitami Institute of Technology, 165 Koen-cho, Kitami, Hokkaido 090-8507, Japan

⁵Faculty of Engineering, School of Earth, Energy and Environmental Engineering, Kitami Institute of Technology, 165 Koen-cho, Kitami, Hokkaido 090-8507, Japan

*Corresponding author: Tel: +81 157 57 7339, Fax: +81 154 57 6253

E-mail: oomae@kushiro-ct.ac.jp

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